

Notice of References Cited	Application/Control No. 10/781,783		Applicant(s)/Patent Under Reexamination OOI ET AL.	
	Examiner David S. Kim		Art Unit 2613	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,559,920 A	09-1996	Chraplyvy et al.	385/123
*	B	US-2002/0021862 A1	02-2002	Zhou et al.	385/24
*	C	US-6,433,923 B1	08-2002	Tanaka et al.	359/337
*	D	US-2003/0007217 A1	01-2003	Fuerst et al.	359/161
*	E	US-6,563,978 B2	05-2003	Matsuoka et al.	385/24
*	F	US-6,650,842 B1	11-2003	Fee et al.	398/147
*	G	US-2004/0028319 A1	02-2004	Ajgaonkar et al.	385/16
*	H	US-2004/0208608 A1	10-2004	Tager et al.	398/147
*	I	US-2004/0208617 A1	10-2004	Essiambre et al.	398/158
*	J	US-6,931,176 B2	08-2005	Kelly, Colin Geoffrey	385/24
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.